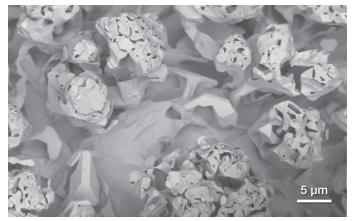
DATASHEET

Phenom ProX G6 Desktop SEM

Desktop SEM with EDS capability for robust, effortless, and versatile elemental analysis







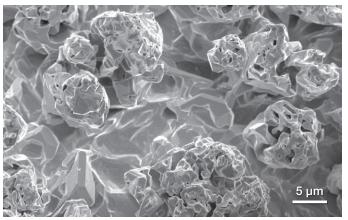
Platinum-coated metal grid (BSD).

The sixth generation of Thermo Scientific Phenom ProX G6 Desktop SEM fills the gap between light microscopy and floor-model SEM analysis, expanding the capabilities of research facilities. It offers fast, high-resolution imaging in addition to an integrated energy dispersive spectroscopy (EDS) detector for robust, easy-to-use, rapid elemental analysis.

Expand your research facility's capabilities

Fast and easy to use, the Thermo Scientific[™] Phenom[™] ProX G6 Desktop SEM can be used to relieve the burden of routine analysis for common samples from floor-model SEM instruments. Instrument configuration and the sample loading mechanism ensure quick imaging with minimal time spent tuning between experiments.

Facility users of any experience level can quickly begin producing high-quality results with the Phenom ProX G6 Desktop SEM. Its long-lifetime CeB₆ source offers high brightness while requiring low maintenance. Additionally, the Phenom ProX G6 Desktop SEM's high stability and small form factor allow it to be used in practically any lab environment because it does not require specialized infrastructure or expert oversight.



Platinum-coated metal grid (SED).

Key Benefits

Expand research capabilities—Offload work from your floor-model SEMs

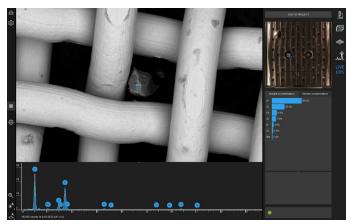
Fully integrated EDS detector—High-resolution imaging at same working distance as EDS analysis for faster workflow

Easy to learn, easy to use—Users of any experience level can quickly start producing results

Fast, high-resolution imaging—Long-lasting, high-brightness CeB_6 electron source

No specialized infrastructure—High stability and small form factor allow it to be used in practically any lab environment

Imaging specifications	
Imaging modes	
Light optical	Magnification range: 20–134x
Electron optical	Magnification range: 160–350,000x
Illumination	
Light optical	Bright field / dark field modes
Electron optical	Long lifetime thermionic source (CeB_6)
Acceleration voltages	Default: 5 kV, 10 kV and 15 kV
	 Advanced mode: adjustable range between 4.8 kV and 20.5 kV imaging and analysis mode
Resolution	• ≤6 nm (SED)
	● ≤8 nm (BSD)
Detector	
Standard	 Energy dispersive spectroscopy detector
	Backscattered electron detector
Optional	Secondary electron detector (enabled for live mixing with BSE)



Live EDS analysis of particles inside metal mesh.

ight optical	Color navigation camera	
Image formats	0	
JPEG, TIFF, PNG		
Image resolution op	tions	
960x600, 1920x1200, 3	3840x2400 and 7680x4800 pixels	
Data storage		
Network, workstation w	vith SSD	
Sample stage		
Computer-controlled motorized X and Y		
Sample size		
• 25 mm diameter (up	to 32 mm as option)	
 35 mm height (up to 100 mm as option) 		
Sample loading time	•	
Light optical	<5 seconds	
Electron optical	<30 seconds	

Element IDentification (EID)

The Phenom ProX G6 Desktop SEM is equipped with an EDS detector to obtain more material insights with element identification via X-ray analysis. Thanks to the design of the SEM column, high-resolution imaging is done at the same working distance as EDS analysis, resulting in an even faster workflow.

Live EDS gives you immediate element identification via point & click in imaging mode, while more advanced analysis, including the optional EDS line scan and EDS fast mapping, can be done via the integrated EID application.

Step-by-step data collection

The dedicated software package, Element IDentification (EID), is used to control the fully integrated EDS detector. Analysis has become as easy as imaging, since there is no need to switch between external software packages or computers. The CeB₆ electron source is used to generate the highest X-ray count rate in its market segment, allowing for fast results.

The EID software package allows you to identify nearly all materials in the periodic table, starting from boron (5) and ranging up to californium (98). It is a perfect analysis tool for a wide range of samples and applications. Projects can be stored locally or on the network, where they can be analyzed at a later stage or offline.

The EID software package runs smart algorithms with advanced peak analysis to optimize the auto-identification functionality, while still allowing for manual adjustments at any time in the analysis process. The intuitive step-by-step process within the software helps you collect all X-ray results in an organized and structured manner.

EDS Specifications	
Detector type	Silicon Drift Detector (SDD)
	Thermoelectrically cooled (LN ₂ free)
Detector active area	25 mm ²
X-ray window	Ultra thin silicon nitride (Si ₃ N ₄) window allowing detection of elements B to Cf
Energy resolution	Mn Kα ≤132 eV
Processing capabilities	Multi-channel analyzer with 2048 channels at 10 eV/ch
Max. input count rate	300,000 cps
Hardware integration	Fully embedded
Software	

Software

- Integrated in Phenom user interface
- Integrated column and stage control
- Auto-peak ID
- Iterative strip peak deconvolution
- Export functions: CSV, JPG, TIFF, ELID, EMSA

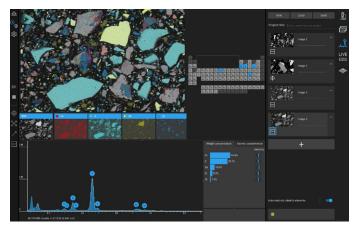
Report

Docx format

System specifications		
Dimensions and weight		
Imaging module	286(w) x 566(d) x 495(h) mm, 50 kg	
Diaphragm vacuum pump	145(w) x 220(d) x 213(h) mm, 4.5 kg	
Power supply	156(w) x 300(d) x 74(h) mm, 3 kg	
Monitor (24")	531,5 (w) x 250 (d) x 515,4 (h) mm; 6,7 kg	
Workstation	 Powerful workstation, including SSD storage and four USB slots 	
	 92.5 (w) x 305.6 (d) x 343.5 (h) mm, 8 kg 	
Requirements		
Ambient conditions		
Temperature	15°C ~ 30°C (59°F ~ 86°F)	
Humidity	Between 20% and 80% RH	
Power	Single phase AC 100–240 Volt, 50/60 Hz, 153 W average, 348 W max	
Recommended table dimensions		
150x75 cm load rating of 100 kg		

150x75 cm, load rating of 100 kg

thermo scientific



Elemental Mapping of a mineral sample ..

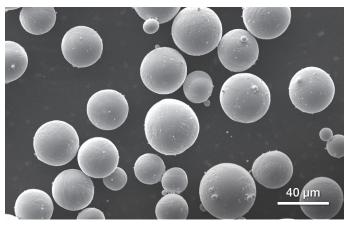
Secondary electron detector

The standard detector in the Phenom ProX G6 Desktop SEM is a four-segment backscattered electron detector (BSD) that yields sharp images and provides topographical contrast information.

A secondary electron detector (SED) is optionally available. The SED collects low-energy electrons from the top surface layer of the sample. It is therefore the perfect choice to reveal detailed sample surface information. The SED can be of great use for applications where topography and morphology are important. This is often the case when studying microstructures, nanostructures or particles. Once installed, the Phenom ProX G6 offers live mixing of backscattered and secondary electrons images to combine compositional and topographic data.

Long-life CeB₆ source

The CeB₆ (cerium-hexaboride) source has several advantages: first, the high brightness it provides compared to tungsten makes it much easier to obtain high-quality images with many details; second, the lifetime of the source is very long, and maintenance can be scheduled, enabling you to obtain the results you are looking for, even after a long (automated) run. The lifetime is extended as much as possible via our intelligent software; the source is hibernated when the Phenom ProX G6 Desktop SEM is not in use. In case the source needs to be replaced, this can be done on-site.



SED image of Titanium particles.

Element Mapping and Line Scan specifications* Element Mapping

Full spectrum mapping and line scan, makes post processing possible including offline element selection and re-quantification

Element selection	User-specified individual element maps, plus BSD and mix image
Selected area	Any size, rectangular
Mapping resolution range	32x32-960x960 pixels
Pixel dwell time range	1–500 ms
Line Scan	
Line Scan resolution range	16–512 pixels
Points dwell time range	10–500 ms
Element selection	Auto ID or manual
Reporting	
Docx format	
SED specifications	
Detector type	Everhart Thornley
* Ontrin al	

* Optional

Find out more at thermofisher.com/phenom-pro-x



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